


<b>Search Notes</b>  	<b>Application/Control No.</b>  10511630	<b>Applicant(s)/Patent Under Reexamination</b>  SHIMIZU ET AL.
	<b>Examiner</b>  ERIN D CHIEM	<b>Art Unit</b>  2883

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
Updated search but maintained Uchida and Verdiell were the most pertinent arts	9/30/08	edc
Updated search; found Jewell to be pertinent to claim 23	5/26/09	edc

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

--	--